10/538929 JC17 Rec'd PCT/PTO 1/3 JUN 2005

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q73500

Masahiro AMEMIYA, et al

Appln. No.: National Stage of PCT/JP2003/015792

Confirmation No.: Unknown Group Art Unit: Unknown

Filed: June 13, 2005 Examiner: Unknown

For: CLEANING AGENT COMPOSITION, CLEANING AND PRODUCTION METHODS

FOR SEMICONDUCTOR WAFER, AND SEMICONDUCTOR WAFER

## INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §§ 1.97 and 1.98

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure under 37 C.F.R. § 1.56, Applicant hereby notifies the U.S. Patent and Trademark Office of the documents which are listed on the attached PTO/SB/08 A & B (modified) form and/or listed herein and which the Examiner may deem material to patentability of the claims of the above-identified application.

One copy of each of the listed documents is submitted herewith, except for the following: U.S. patents and/or U.S. patent publications; and co-pending non-provisional U.S. applications filed after June 30, 2003.

The present Information Disclosure Statement is being filed: (1) No later than three months from the application's filing date; (2) Before the mailing date of the first Office Action on the merits (whichever is later); or (3) Before the mailing date of the first Office Action after

10/538929

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INFORMATION DISCLOSURE STATEMENT

U.S. Appln. No.: National Stage of PCT/JP2003/015792

Attorney Docket No. Q73500

filing a request for continued examination (RCE) under §1.114, and therefore, no Statement

under 37 C.F.R. § 1.97(e) or fee under 37 C.F.R. § 1.17(p) is required.

In compliance with the concise explanation requirement under 37 C.F.R. § 1.98(a)(3) for

foreign language documents, Applicant encloses herewith a copy of a Communication from a

foreign patent office in a counterpart application citing such documents (International Search

Report for PCT/JP2003/015792 dated March 9, 2004), together with an English-language

version (if not already included) of at least that portion of the Communication indicating the

degree of relevance found by the foreign patent office.

The submission of the listed documents is not intended as an admission that any such

document constitutes prior art against the claims of the present application. Applicant does not

waive any right to take any action that would be appropriate to antedate or otherwise remove any

listed document as a competent reference against the claims of the present application.

The USPTO is directed and authorized to charge all required fees, except for the Issue

Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any

overpayments to said Deposit Account. A duplicate copy of this paper is attached.

Respectfully submitted,

Registration No. 33,725

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Date: June 13, 2005

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Substitute for Form 1449 A & B/PTO							
INFORM	TATION DISC	r os	HIDE	Application Number	PCT/JP2003/015792		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Confirmation Number	Unknown		
				Filing Date	June 13, 2005		
	,		,	First Named Inventor	Masahiro AMEMIYA		
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				Examiner Name			
Sheet	1	of	1	Attorney Docket Number	Q73500		

U.S. PATENT DOCUMENTS							
Examiner Cite No.1		Document Number					
	Cite No. <sup>1</sup>	Number	Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document		
	-	US 2001/0025017	Al	09/27/2001	MASAHIRO AMEMIYA, ET AL		
		US 2002/0016272	A1	02/07/2002	MASAHIKO KAKIZAWA, ET AL		
		US 2002/0022582	Al	02/21/2002	MASAYUKI TAKASHIMA		
		US					
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FOREIGN PATENT DOCUMENTS								
Examiner Cite Initials* No.1	Cite	Foreign Patent Document			Publication Date	Name of Patentee or		
		Country Code <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)	MM-DD-YYYY	Applicant of Cited Document	Translation <sup>6</sup>	
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NON PATENT LITERATURE DOCUMENTS					
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Examiner Signature		Date Considered	 

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>&</sup>lt;sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup>See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or in the comment box of this document. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to indicate here if English language Translation is attached.